

PATENT APPLI

Admit!

In re the Application of

Yasushi YAMAZAKI et al.

July 1, 2003

Group Art Unit: 2811

Application No.: 09/970,766

Examiner:

S. Hu

Filed:

October 5, 2001

Docket No.: 110791

For:

METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC EQUIPMENT

> LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified pate application. The shortened statutory period having expired June 11, 2003, an extension of time for a period month is hereby requested. Attached hereto is our Check No. 143720 in the amount of \$110.00 in payment for:

X	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
	Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
	Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Registration No. 27,075

Jeffery M. Lillywhite Registration No. 53,220

JAO:JML/vgp

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 07/02/2003 CCHAU1 00000137 09970766

DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

02 FC:1251

110.00 OP